

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Eiji Nishibe et al. Art Unit : 2812
Serial No. : 10/809,011 Examiner : Walter Lee Lindsay, Jr.
Filed : March 25, 2004 Conf. No. : 7829
Title : MANUFACTURING METHOD FOR A SEMICONDUCTOR DEVICE WITH
REDUCED LOCAL CURRENT

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF SEPTEMBER 20, 2006

Please amend the above-identified application as follows: